

IFW



PATENT
8007-1089

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Yasuo NAKAZAWA et al.

Conf. 5018

Application No. 10/528,355

Group 1724

Filed March 18, 2005

Examiner F. Lawrence, Jr.

METHOD FOR REMOVING HARMFUL SUBSTANCES
IN VENT GAS

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 25, 2007

Sir:

In response to the Official Action mailed March 28, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.